

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE
BEFORE THE BOARD OF PATENT APPEALS AND INTERFERENCES**

In re Application of: Yoshinobu KIMURA et al: Group Art Unit: 2813

Application No. 10/019,407 : Examiner: Laura M. SCHILLINGER

Filed: March 25, 2002 :

For: POLYCRYSTALLINE SEMICONDUCTOR THIN FILM SUBSTRATE
MANUFACTURING METHOD OF THE SAME, SEMICONDUCTOR DEVICE
AND ELECTRONIC DEVICE

**NOTICE OF APPEAL FROM THE PRIMARY EXAMINER
TO THE BOARD OF APPEALS**

Mail Stop: APPEALS

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

February 11, 2008

Sir:

In accordance with the provisions of 37 C.F.R. §41.31, Applicants hereby appeal from the rejection of claim 3 and the objection of claim 4 as set forth in the Final Office Action mailed September 10, 2007.

A Petition for a two-month extension of time, and the requisite fee (\$460.00), is enclosed herewith.

Also enclosed is a credit card payment form, Form PTO-2038, authorizing the additional amount of \$ 510.00 to be paid for the requisite Appeal Fee.

Respectfully Submitted,

ANTONELLI, TERRY, STOUT & KRAUS, LLP

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